

## RING RESONATOR WITH RARE EARTH INTEGRATED ON WAVEGUIDES

**LABORATORY :** Institut Lumière Matière  
**IN COOPERATION WITH :** inl

**LEVEL :** M2  
**TEAM(S) :** MNP

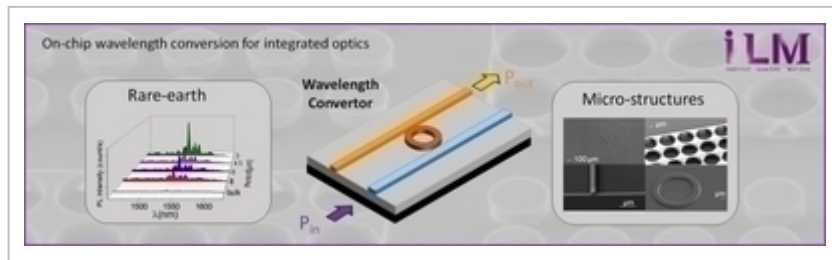
**CONTACT(S) :** GASSENQ Alban  
PEREIRA Antonio

**CONTACT(S) DETAILS :** alban.gassenq[at]univ-lyon1.fr / Tel. 0472431208  
antonio.pereira[at]univ-lyon1.fr / Tel. 0472448335

**KEYWORD(S) :** integrated optics / photonics / rare earth

### SCIENTIFIC CONTEXT :

Photonic Integrated Circuit aims at miniaturizing and combining several optical devices onto a planar substrate to create power efficient and complex functionalities on-chip for many applications like sensing or telecommunication[1].



Many building blocks are already available for passive devices (filter, coupler, modulator...) as well as active components (source, detector...). For these functions, the ring resonator is a well spread design for both passive[2] and active[3] devices. However, the manufacturing of such components to reach high quality factors is usually complex and costly, in particular for the etching process. It consists in the partial erosion of a surface through a mask (e.g. photoresist) adding a difficult, pollutant and expensive processing step which can also induce extra losses due to the degradation of materials along etched sidewalls which potentially reduce the performance of photonics devices [4], [5]. Furthermore it is difficult to couple a ring resonator to a waveguide with a different materials at the same level [6]. Pulsed Laser Deposited (PLD) based lift off processing permits to overcome those limitations [7].

### MISSIONS :

In this project, we want to develop ring resonators made by pulsed laser deposition and liftoff processing [7-9]. The doped microrings will be coupled to undoped waveguides for lasing applications.

The student will work on the micro-devices fabrication (PLD and lithography in cleanroom) and the optical characterizations (measurements of the micro-devices and associated modeling).

### OUTLOOKS :

A PhD is planned after the M2 internship (ANR IDEAL project 2025-28).

### BIBLIOGRAPHY :

- [1] Baets et al., APL Photonics, 2016
- [2] Kazanskiy et al. Micromachine 2023
- [3] Li et al., Nat. Commun 2022
- [4] Megalini et al. Phys. Status Sol. 2016
- [5] Takenaka et al., Opt. Express 2012
- [6] Bradley et al., Opt. Express 2014
- [7] Gassenq et al., Opt. Express 2021
- [8] Gassenq et al., Appl. Phys. A, 2023
- [9] Gassenq et al., Opt. Lett. 2023